



Patent
257/040
P00-0022

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of:

Bryer, James

Serial No.: 09/658,395

Filed: September 8, 2000

For: SPRAY NOZZLE SYSTEM FOR A
SEIMICONDUCTOR WAFER CONTAINER
CLEANING APPARATUS

Group Art Unit: 1746

Examiner: Zeinab El-Arini

8/A
8/13/02

RECEIVED

MAY 21 2002

TC 1700

COPY OF PAPERS
ORIGINALLY FILED

AMENDMENT AND RESPONSE

Box AMENDMENT
Commissioner for Patents
Washington, D.C. 20231

Sir:

In reply to the February 8, 2002 Office Action, please amend the above-identified application
as follows:

IN THE SPECIFICATION

Please amend the Specification as follows:

LA-229340.1

CERTIFICATE OF MAILING
(37 C.F.R. §1.8a)

I hereby certify that this paper (along with any referred to as being attached or enclosed) is being deposited with the
United States Postal Service on the date shown below with sufficient postage as First Class Mail in an envelope
addressed to the Box Fee Amendment, Commissioner for Patents, Washington, D.C. 20231.

May 7, 2002
Date of Deposit

Laura Murphy
Name of Person Mailing Paper

Signature of Person Mailing Paper

05/20/2002 YPOLITE1 00000044 09658395 504.00 OP
01 FC:102

A